



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#4
U.S.
1/24/02

In re PATENT APPLICATION of

Seung-pil Chung et al.

Group Art Unit: 1765

Serial No.: 09/689,814

Examiner: Tran, Binh X

Filed: October 13, 2000

For: METHOD FOR REMOVING OXIDE LAYER AND SEMICONDUCTOR
MANUFACTURING APPARATUS FOR REMOVING OXIDE LAYER

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Honorable Commissioner of
Patents and Trademarks,
Washington, D.C. 20231

Sir:

RECEIVED
JAN 28 2002
TC 1700

In response to the Office Action of December 20, 2001, Applicants elect the invention of Group II, Claims 7-11, 23-29, drawn to apparatus. The election is without traverse.

Respectfully submitted,

VOLENTINE FRANCOS, PLLC


Adam C. Volentine
Registration No. 33,289

12200 Sunrise Valley Drive, Suite 150
Reston, Virginia 20191
Telephone No.: (703) 715-0870
Facsimile No.: (703) 715-0877

Dated: January 18, 2002